



PATENT
Dkt. No. AMAT/5617/CMP/CMP/RKK

1765

#7/13/03
6/23/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Hsu et al.

Serial No.: 09/939,323

Confirmation No.: 3877

Filed: August 24, 2001

For: METHOD FOR DISHING
REDUCTION AND FEATURE
PASSIVATION IN POLISHING
PROCESSES

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

§§§§§ Group Art Unit: 1765

§§§§§ Examiner: MACKEY, TERENCE

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| CERTIFICATE OF MAILING 37 CFR 1.8 | |
| I hereby certify that this correspondence is being deposited on <u>6/13/03</u> with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450. | |
| <u>6/13/03</u> | <u>Kent R. Zell</u> |
| Date | Signature |

Dear Sir:

RESPONSE TO OFFICE ACTION DATED FEBRUARY 19, 2003

In response to the Office Action dated February 19, 2003, having a shortened statutory period for response set to expire on May 19, 2003, and in further response to Notice of Non-Compliant Amendment (Voluntary Revised Practice) dated May 29, 2003, having a period of response set to expire on June 29, 2003, please enter this response and reconsider the claims pending in the application for reasons discussed below. The Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/5617/CMP/CMP/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.